

Beam Energy Measurement System at BEPCII

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On behalf of the BEMS group:

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Hawaii University (USA)

IHEP(CHINA)

Motivation

Why we build the accurate beam energy measurement system in the “ τ -c” energy region ?

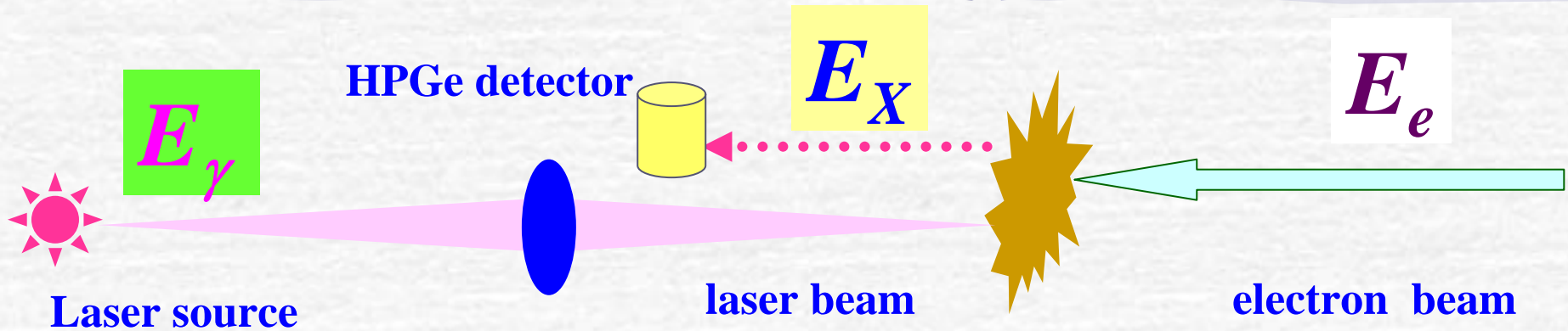
- The τ -lepton mass determination

$$M_{\tau} = 1776.82 \pm 0.16 \text{ MeV}/c^2$$

τ -lepton is fundamental particle, its mass is an important parameter of the Standard Model.

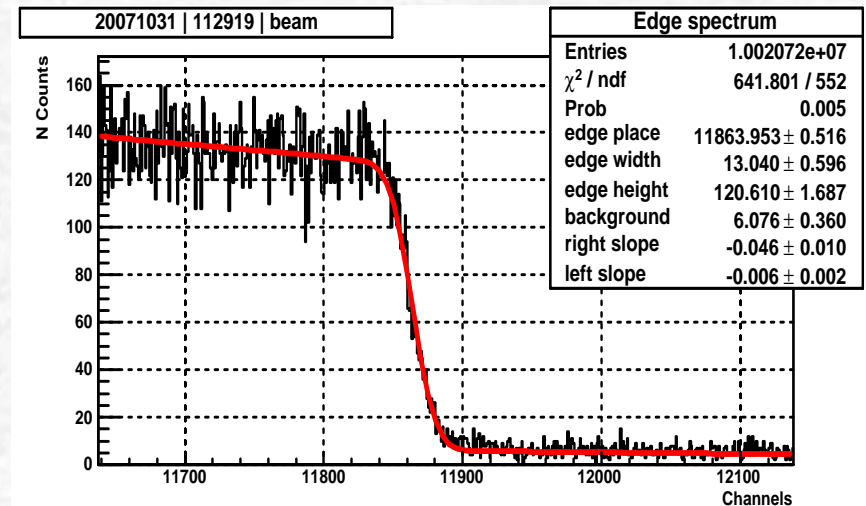
- The masses of ψ and D mesons are of interest.
- Useful tool to monitor the collider.

Compton Backscattering

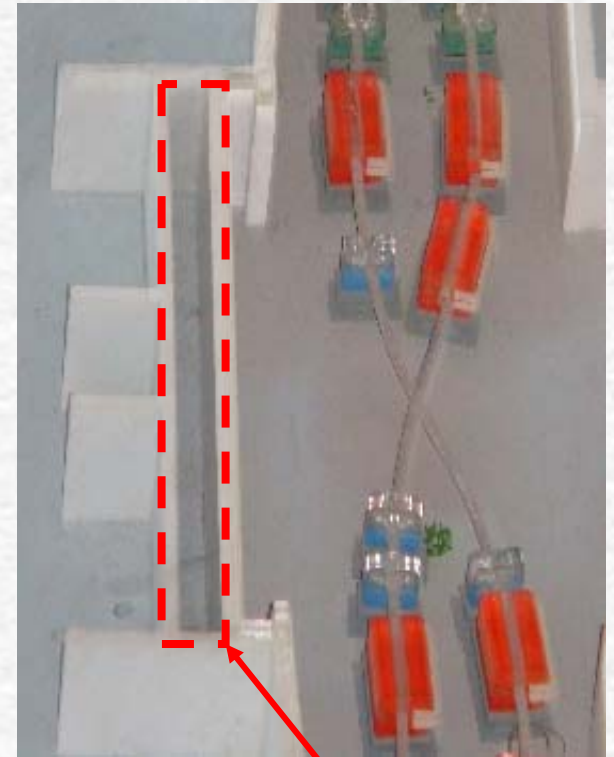
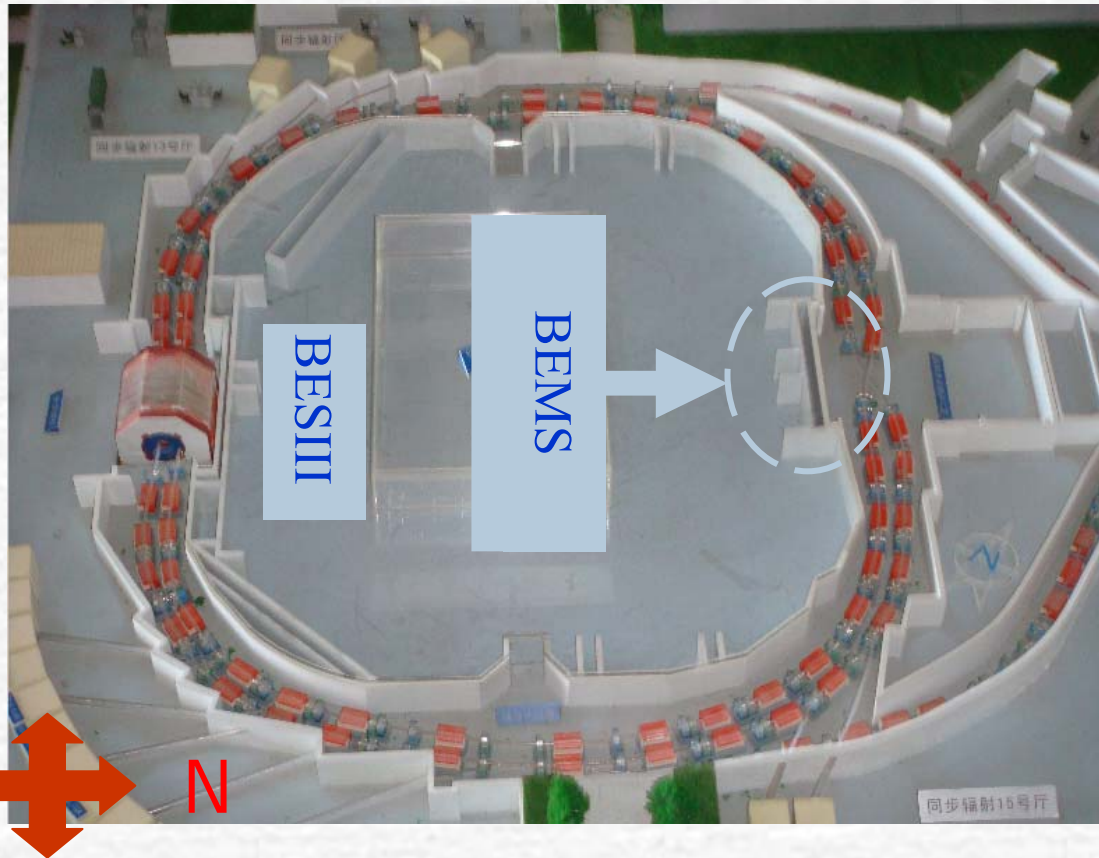


The beam energy E_e is determined by the maximum energy E_X

$$E_e = \frac{E_X}{2} \left[1 + \sqrt{1 + \frac{m_e^2}{E_\gamma E_X}} \right]$$



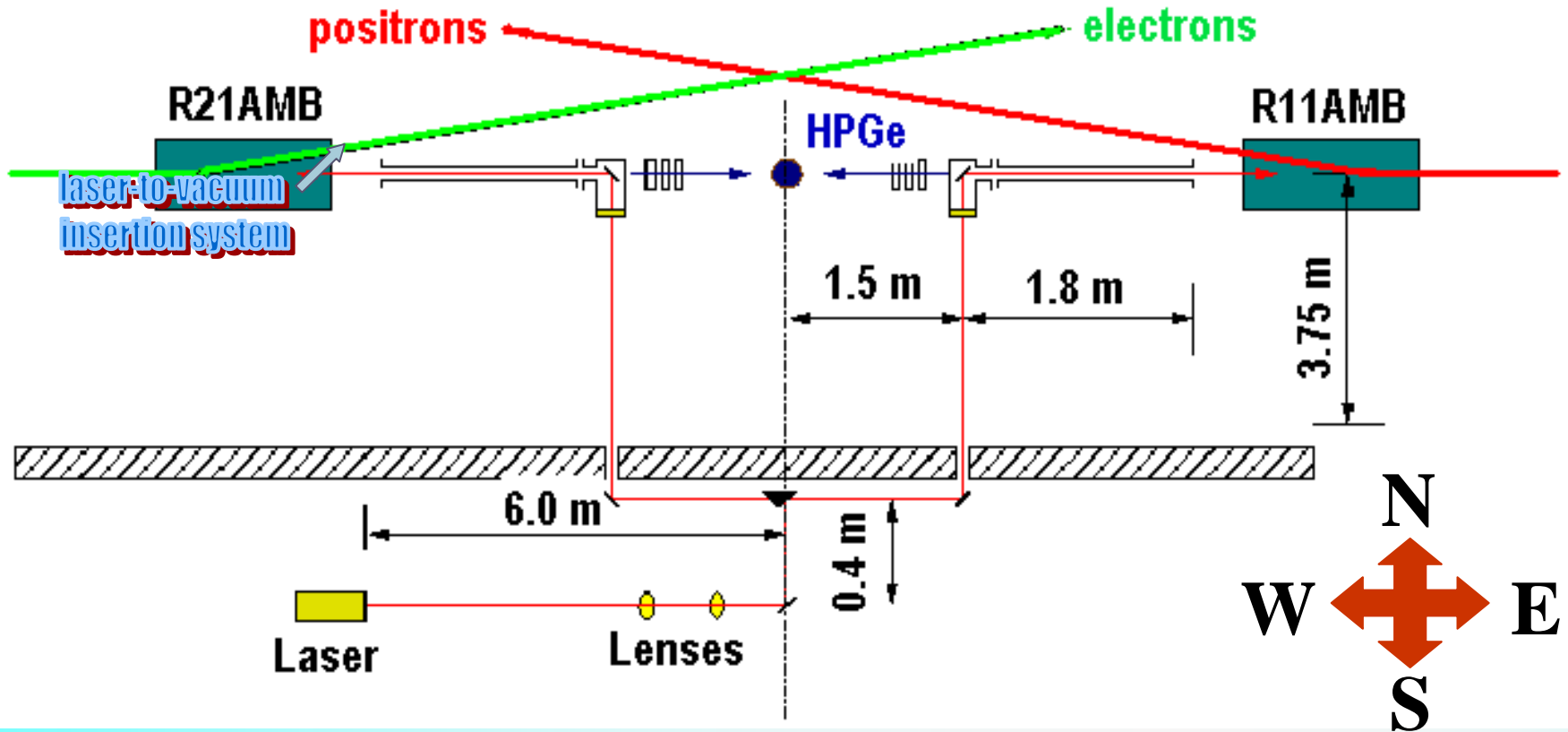
BEPC-II electron-positron storage ring



Corridor where optics system located

The beam energy measurement system locates at the north crossing point.

Sketch map of BEMS



Laser and optics system

HPGe detection system

Laser to beam interaction system

Data acquisition system

Coherent CO₂ laser

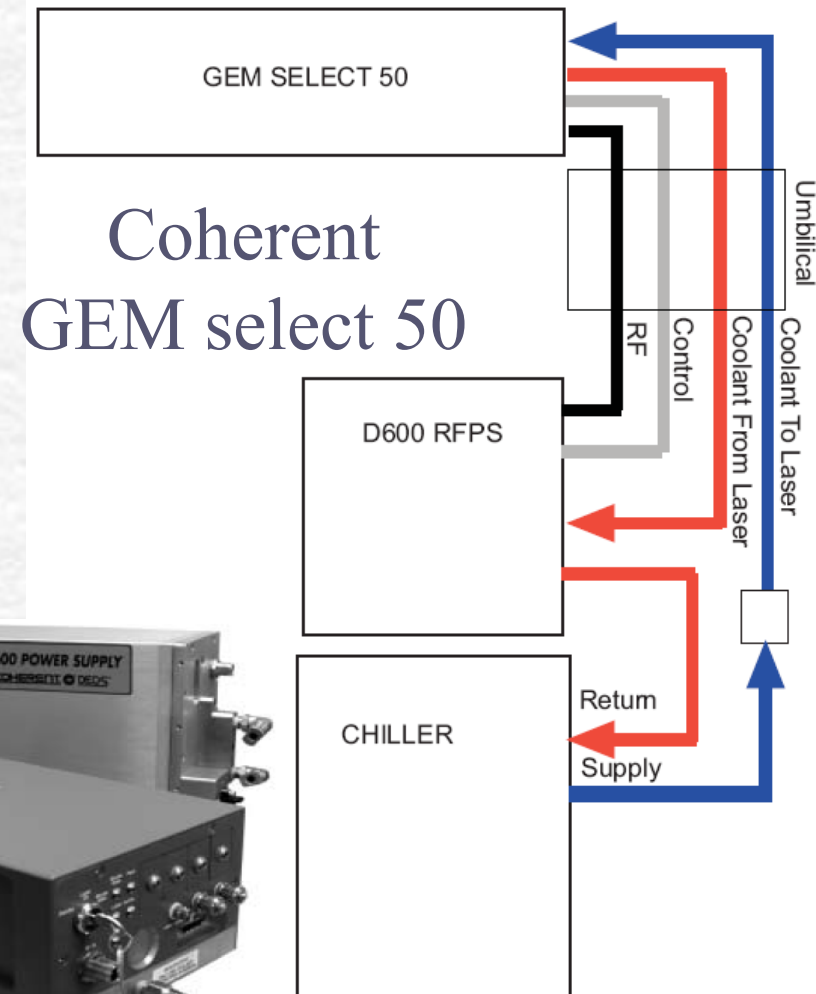
$\lambda = 10.835 \mu\text{m}$



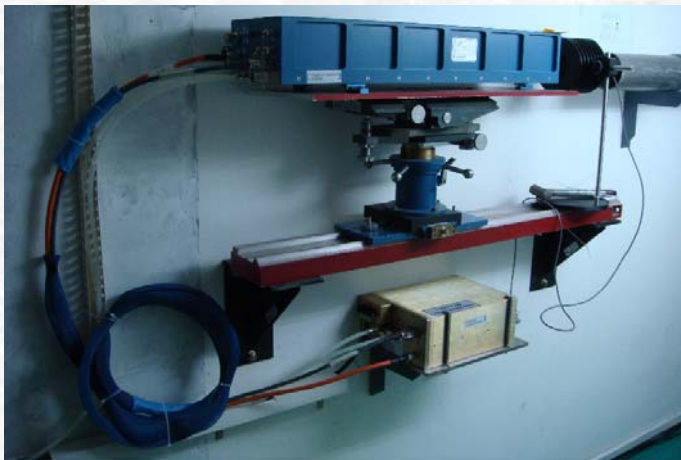
*Lytron CR011H03BC
circulating chillers*



Agilent 6573A power supply



Laser and Optics system



wavelength $\lambda = 10,835231 \mu\text{m}$
power $P = 25 \text{ W}$.



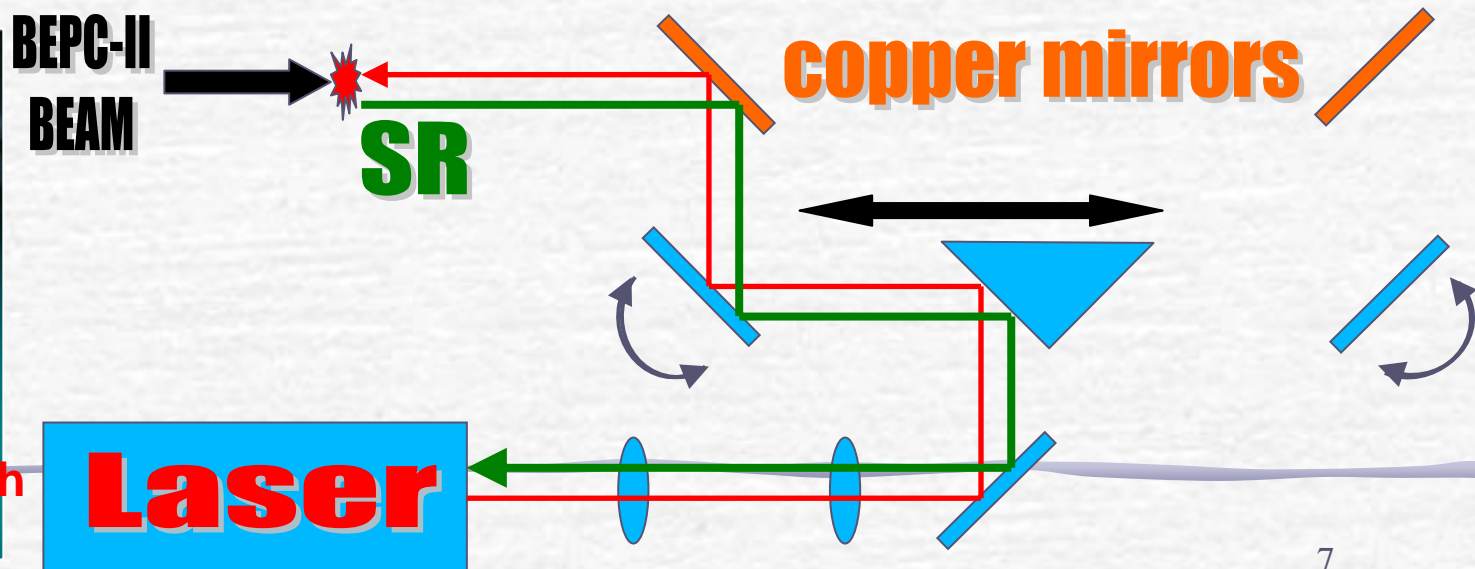
Two ZnSe lenses
focal length $f = 40 \text{ cm}$



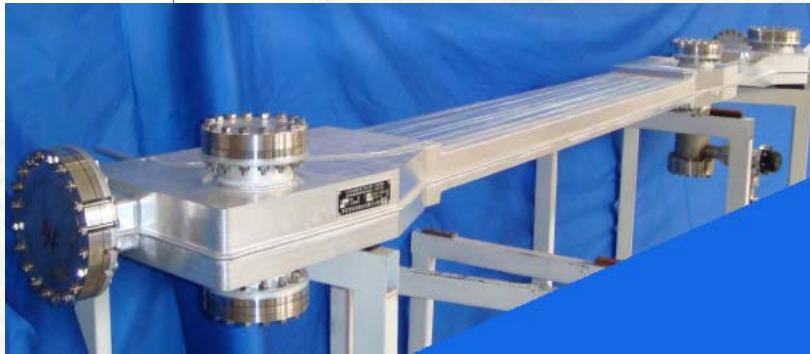
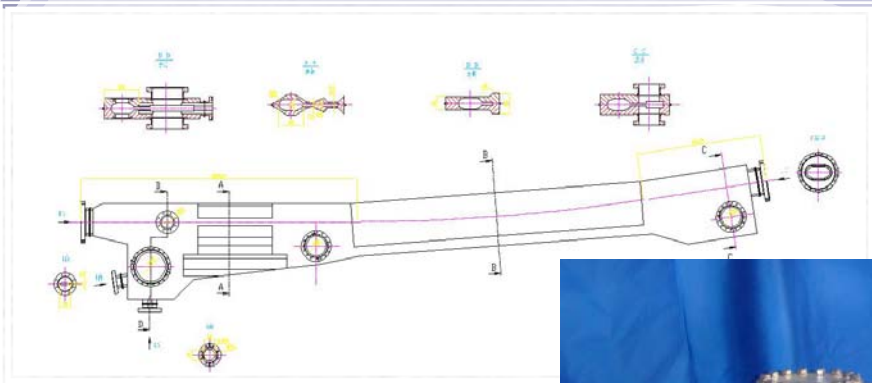
Movable reflector prism



Two mirrors with
step motors



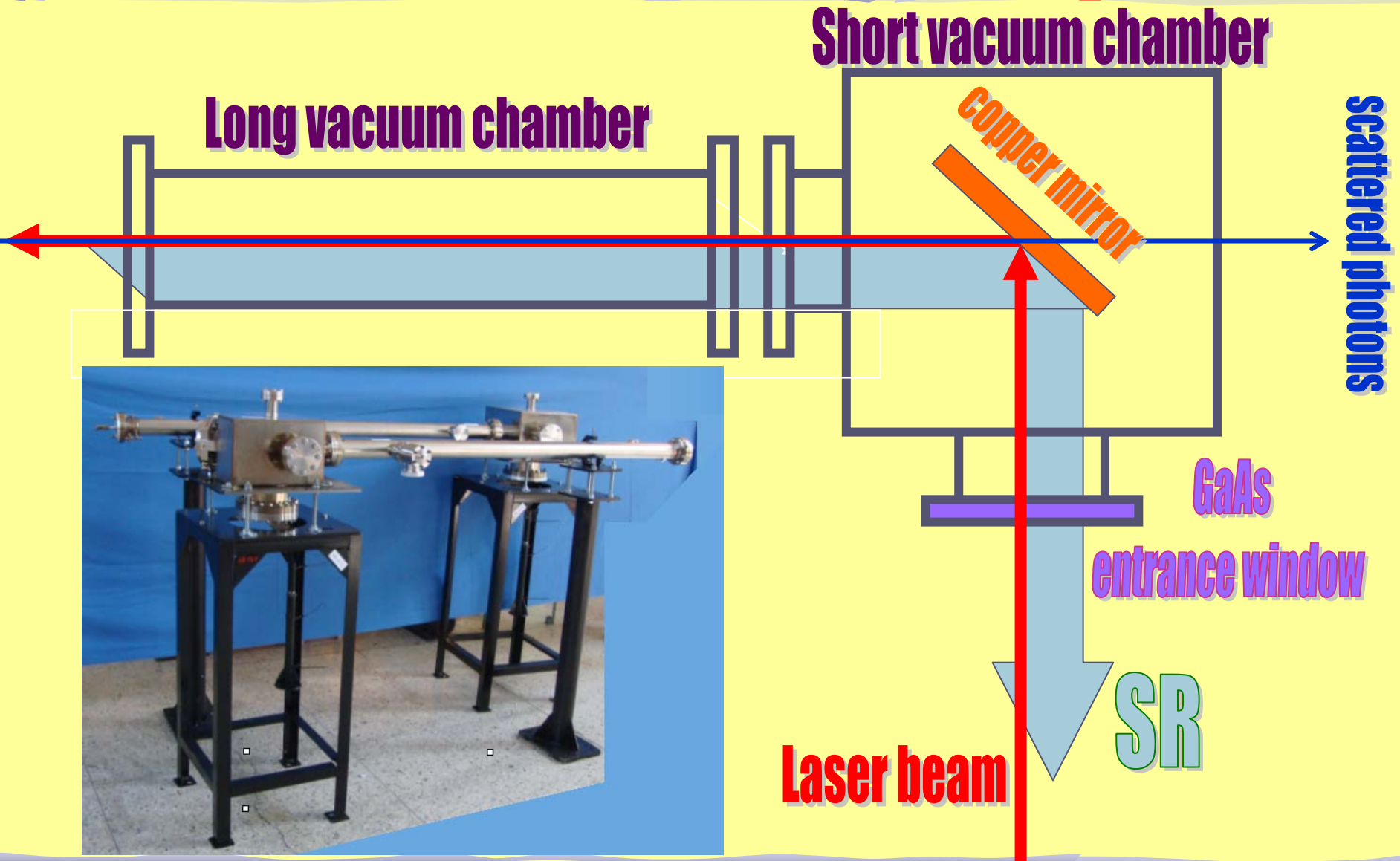
Reformed vacuum chamber



Installation
Alignment

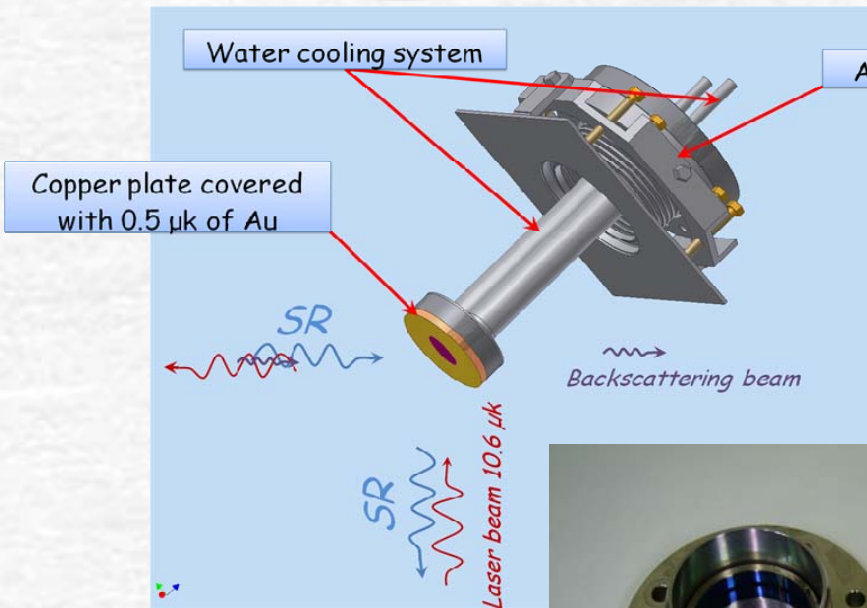


laser-to-vacuum insertion part



Pressure less than 5×10^{-10} mbar

Copper mirror and High vacuum GaAs viewport

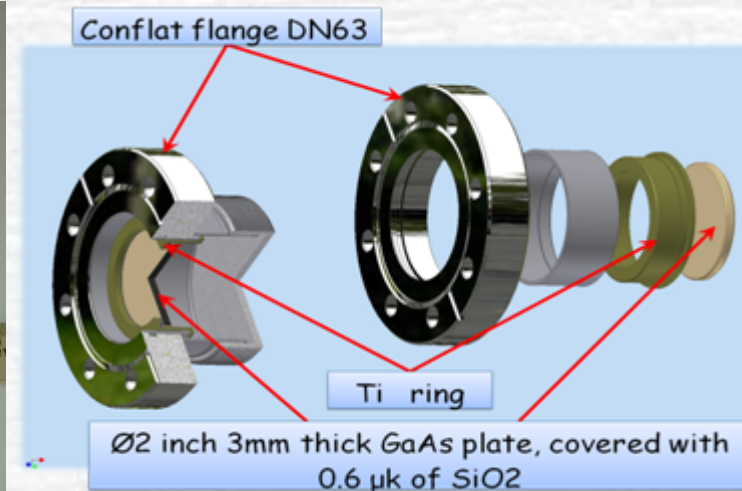


The mirror is mounted to the support.

Support can be turned by bending the vacuum flexible bellow, so the angle between the mirror and the laser can be adjusted as necessary.

The SR light falls on the mirror and heats the mirror. Water cooling system is used.

The viewport is GaAs crystal plate with $\varnothing 2$ inch and thickness of 3mm



GaAs plate was covered with 0.6 μm of SiO_2 and brazed with lead alloy to titanium ring. The titanium ring was brazed with AgCu alloy to the stainless steel ring. The steel ring was welded to stainless steel DN40 flange.

The viewport can be heated up to 250 $^{\circ}\text{C}$, has transparency $\sim 66\%$ at $\lambda = 10.6 \mu\text{m}$.



**chamber
installation**



**Pump
Installation**

laser-to-vacuum insertion part



Alignment



**Baking 24 hours
Pressure:
 $1.5 \sim 4.5 \times 10^{-10}$ Torr**

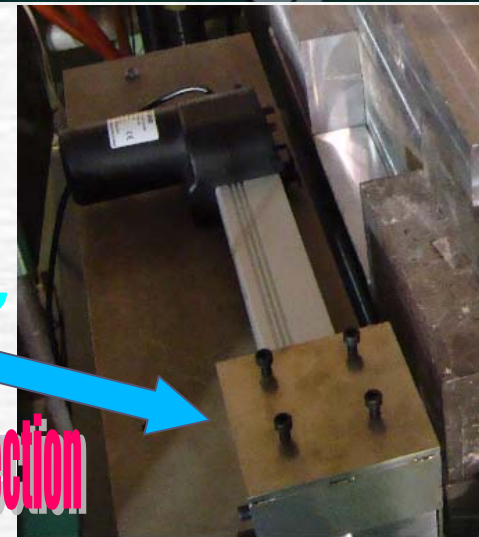
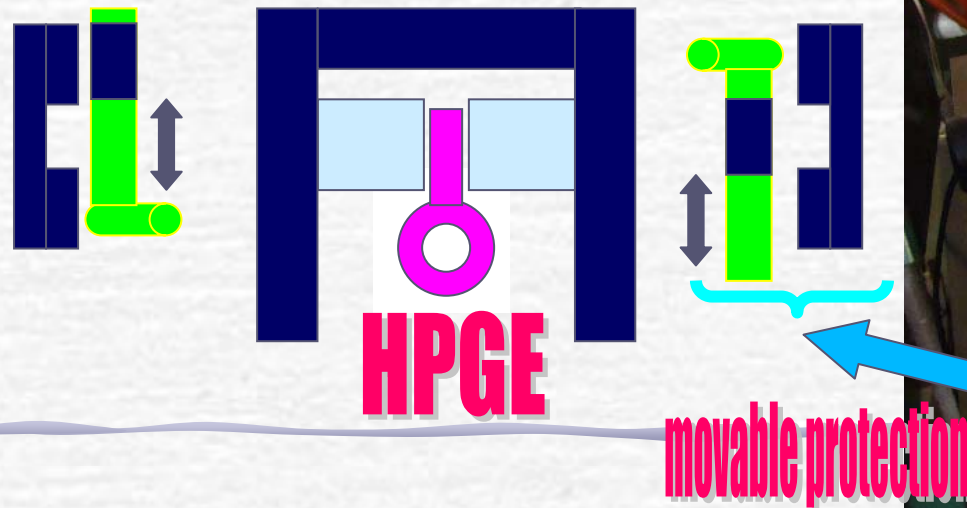


Coaxial HPGe detector (ORTEC GEM10P4-70)

Size: \varnothing 57.8 mm, height 52.7 mm
detection efficiency : about 10%
energy resolution $\sim 10^{-3}$

lead and paraffin are added to suppress
the low energy photons.

Movable protection is used at the other
side of beam direction to reject the high
energy photons.



Installation of BEMS

Vacuum chamber

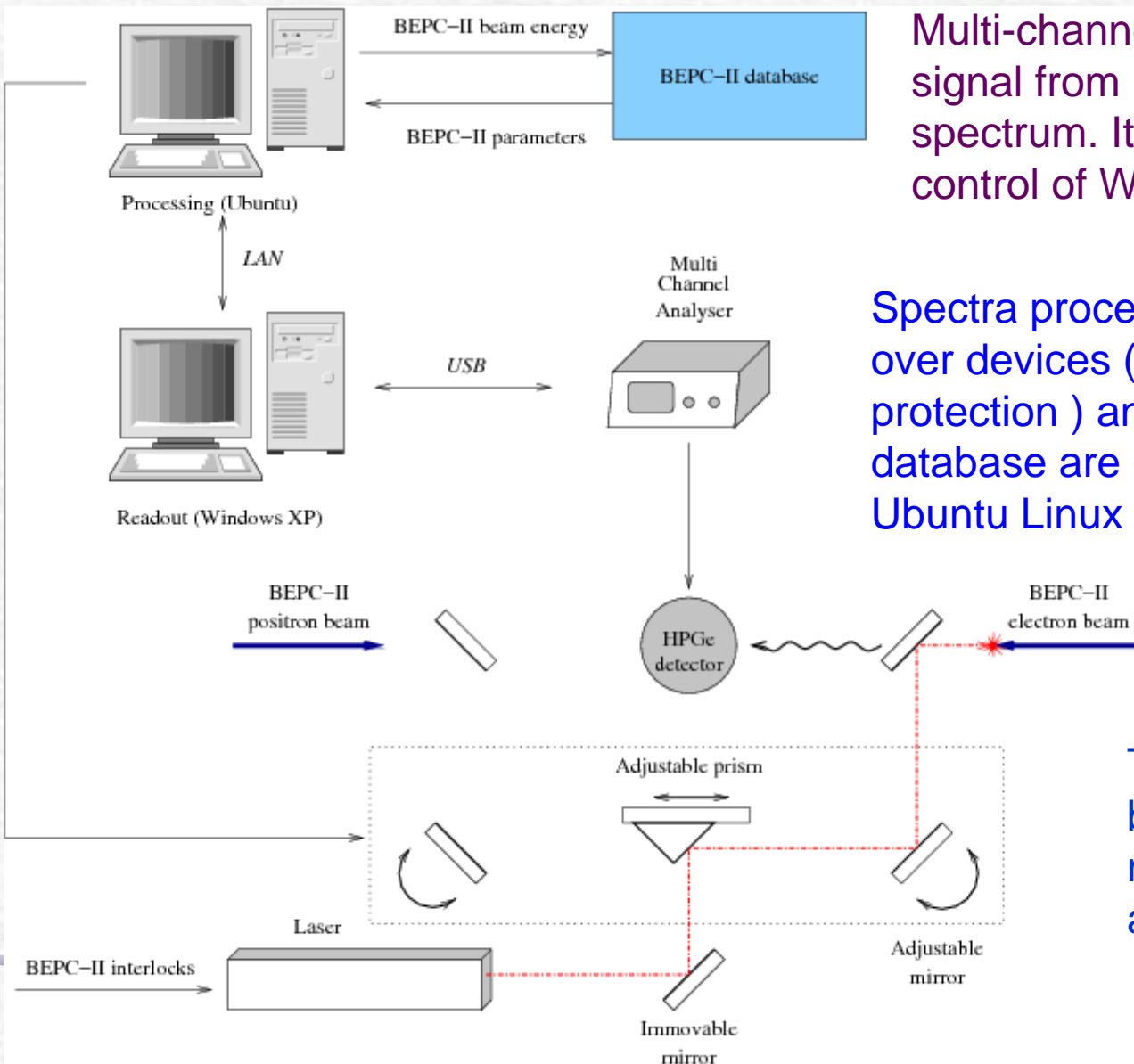
Laser vacuum insertion system

Detection system

Laser and optics system



Data acquisition system



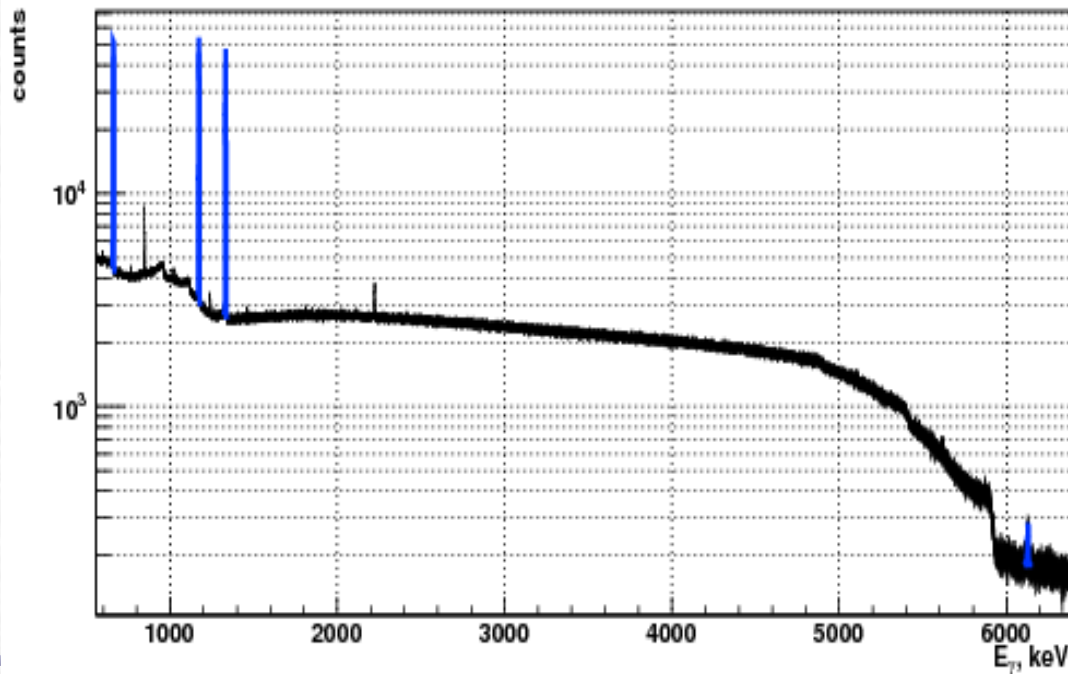
Multi-channel analyser digitises the signal from HPGe and converts it to spectrum. It is connected to PC under control of Windows XP

Spectra processing, monitoring, control over devices (mirrors, movable prism and protection) and exchange with BEPC-II database are concentrated in PC under Ubuntu Linux

The process of the beams energy measurement is fully automated

Data processing

- HPGe energy scale calibration;
- Fitting of the Compton edge
- calculation of the beam energy



Lines used for calibration.

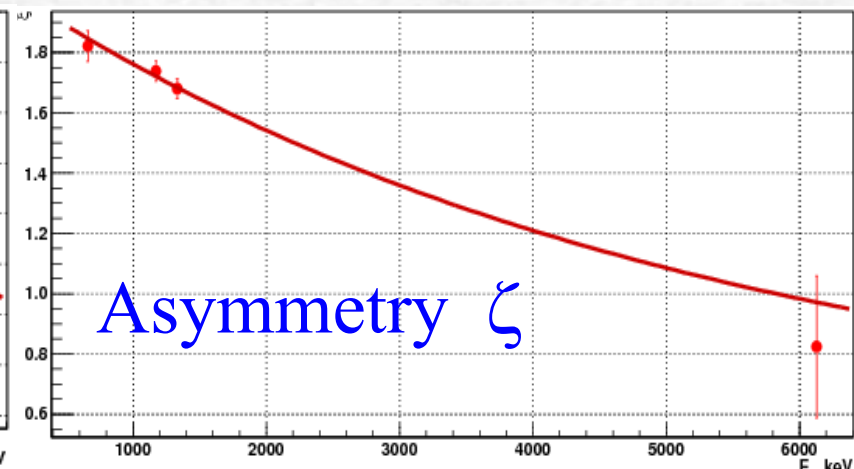
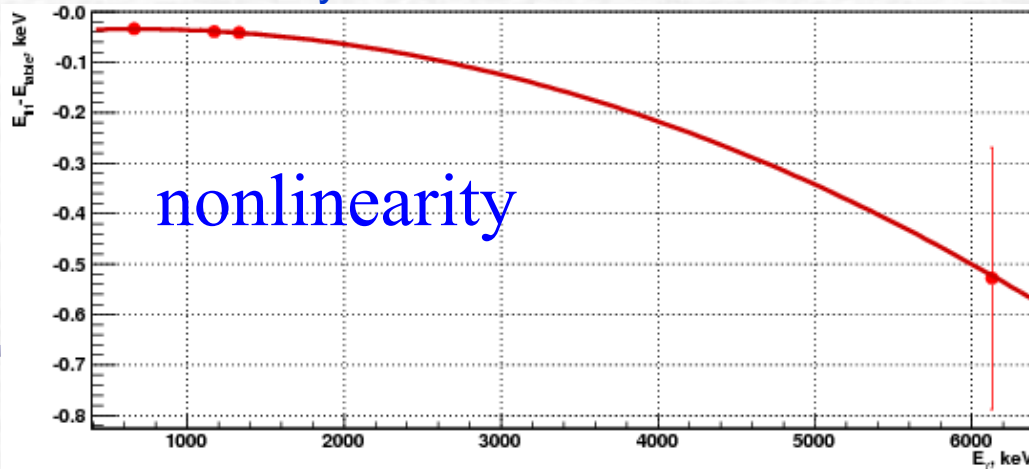
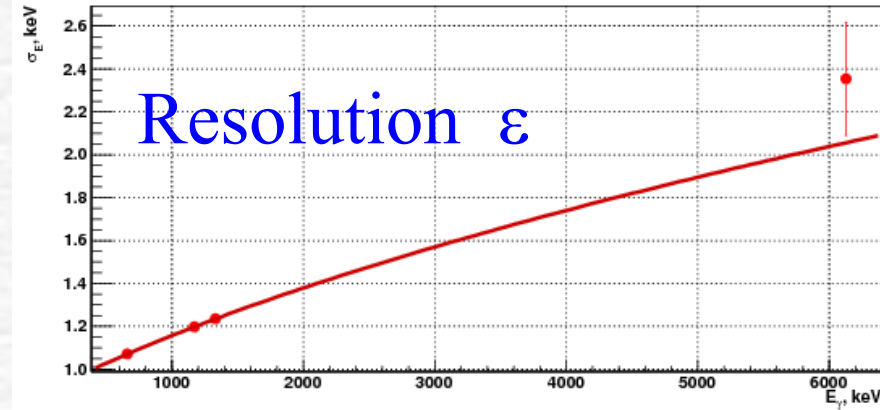
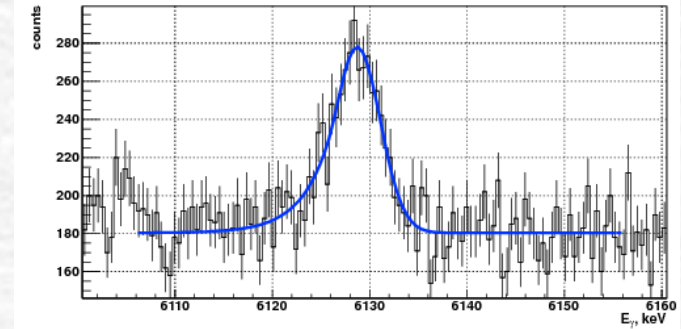
| | |
|-------------------|-----------------------------------|
| ^{137}Cs | $E_{\gamma}=661.656 \text{ MeV}$ |
| ^{60}Co | $E_{\gamma}=1173.228 \text{ MeV}$ |
| ^{60}Co | $E_{\gamma}=1332.492 \text{ MeV}$ |
| $^{16}\text{O}^*$ | $E_{\gamma}=6129.226 \text{ MeV}$ |

HPGe scale calibration procedure

- 1) The peaks searching and identification
- 2) Peaks which correspond to calibration lines are fitted by response function:

$$f(x, x_0, \sigma, \xi) = \frac{N}{\sqrt{2\pi}\sigma} \begin{cases} \exp\left\{-\frac{(x-x_0)^2}{2\sigma^2}\right\}, & x > x_0 - \xi\sigma \\ \exp\left\{\frac{\xi^2}{2} + \frac{(x-x_0)^2}{2\sigma^2}\right\}, & x < x_0 - \xi\sigma \end{cases}$$

- 3) Using the results of the fits the energy dependence of the response function parameters and HPGe detector scale nonlinearity are obtained



Fit of Compton edge

The edge of backscattered photons spectrum is fitted by the function, which takes into account:

- the “pure” edge shape,
- detector's response function,
- energy spread of backscattered photons due to the energy distribution of the collider beam

The edge position ω_{\max} and the Compton photons energy spread σ_{ω} are obtained from the fit.

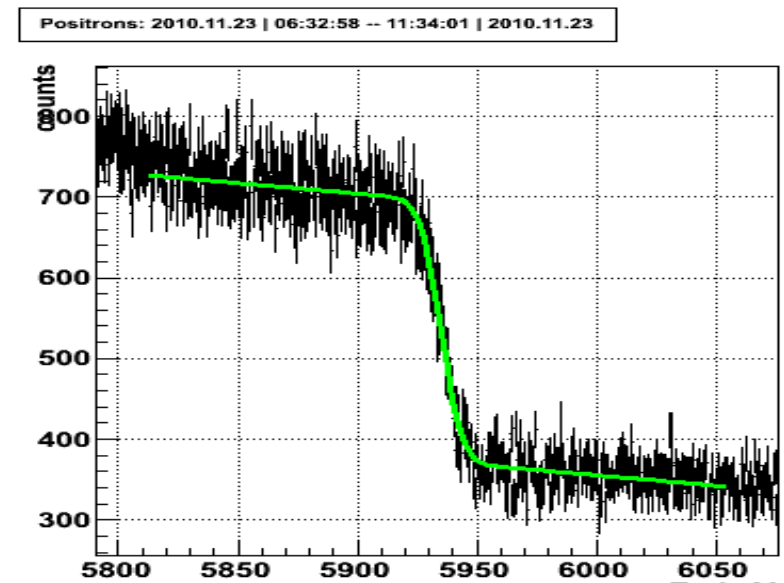
The average beam energy in the north crossing point is calculated as:

$$\varepsilon_{n\text{ip}} = \frac{\omega_{\max}}{2} \left(1 + \sqrt{1 + \frac{m_e^2}{\omega_{\max} \omega_0}} \right)$$

Taking into account the energy losses due to SR:

$$\varepsilon_{s\text{ip}} (\text{MeV}) = \varepsilon_{n\text{ip}} (\text{MeV}) + 4.75 \cdot 10^{-3} \times (0.001 \cdot \varepsilon_{n\text{ip}} (\text{MeV}))^4$$

Beam energy in the south interaction point

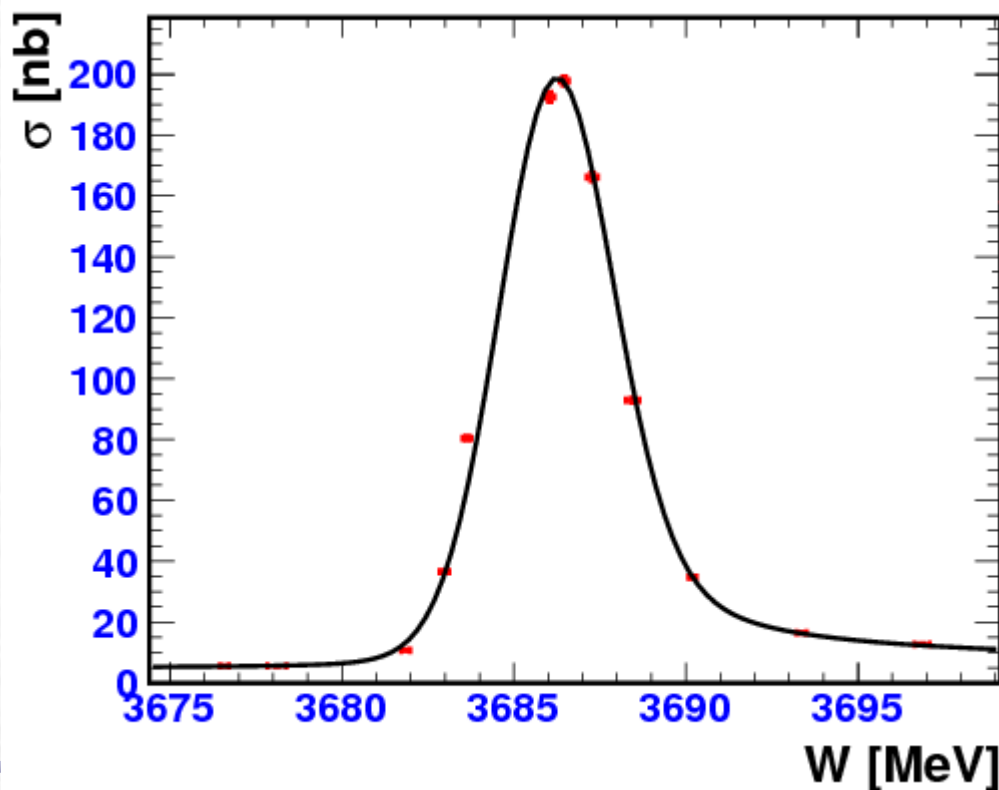


$$S_2(x, x_0, \sigma, \sigma_s, \xi) = \frac{N}{2\sqrt{2\pi}} \times \left[\frac{1}{\sigma} \exp\left(\frac{\xi^2}{2} \left(1 + \frac{\sigma_s^2}{\sigma^2}\right) + \frac{\xi x}{\sigma}\right) \cdot \text{erfc}\left(\frac{\xi(\sigma^2 + \sigma_s^2) + x\sigma}{\sqrt{2}\sigma\sigma_s}\right) + \frac{1}{\sqrt{\sigma^2 + \sigma_s^2}} \exp\left(-\frac{x^2}{2(\sigma^2 + \sigma_s^2)}\right) \cdot \text{erfc}\left(-\frac{\xi(\sigma^2 + \sigma_s^2) + x\sigma}{\sqrt{2}(\sigma^2 + \sigma_s^2)\sigma_s}\right) \right]$$

$$S_3(x, \sigma, \sigma_s, \xi) = \int_x^{+\infty} S_2(y) dy$$

BEMS performance

The accuracy of beam energy measurement was studied by comparison of $\psi(2s)$ resonance mass 3686.09 ± 0.040 MeV, with its value obtained using the energy obtained using BEMS data.



Two scans of $\psi(2s)$ with integrated luminosity about 4 pb^{-1} .

Mass difference:

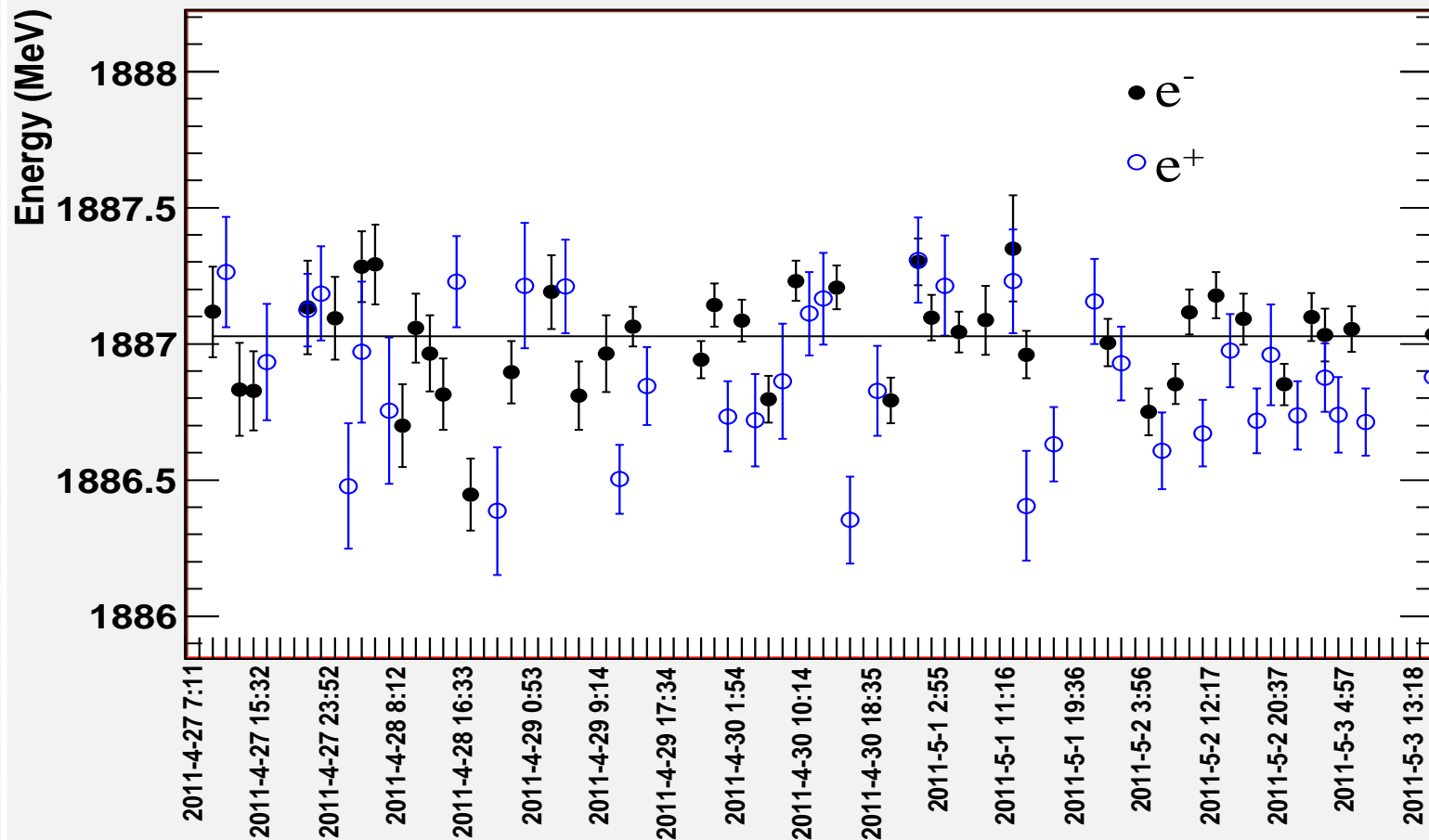
$$\Delta m = m - m_{\psi} = 0.02 \pm 0.05 \text{ MeV}$$

Deviation of the measured beam energy of the beam from true value:

$$\delta \varepsilon = \frac{\Delta m}{2} = 0.01 \pm 0.03$$

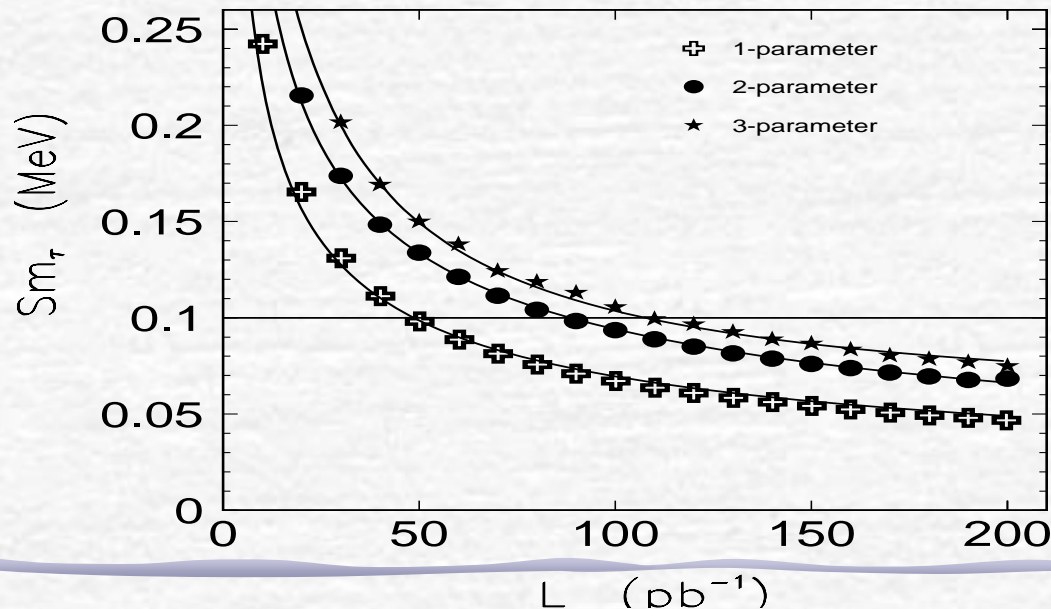
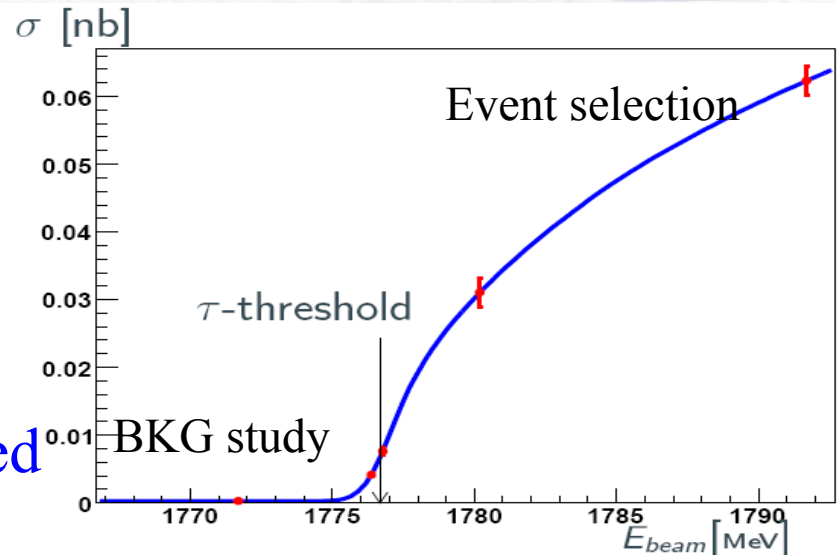
Accuracy of the BEMS: $\delta \varepsilon / \varepsilon \sim 2 \times 10^{-5}$

Stable performance



Data taking design

The τ mass scan will be performed
Considering the possible efficiency
and background variations, reliable
 χ^2 check, 5 points design are selected



Luminosity allocation:
Background: 10%
Threshold: 70%
High energy region: 20%

Conclusions

The BEMS was designed, constructed and put into operation

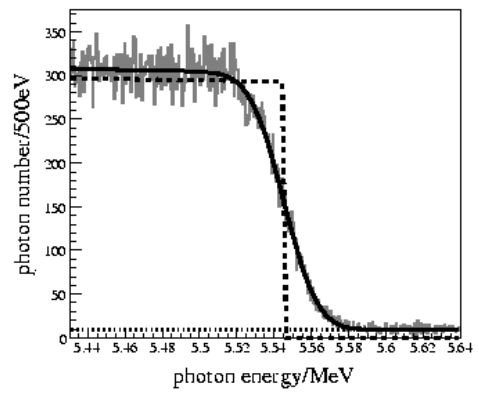
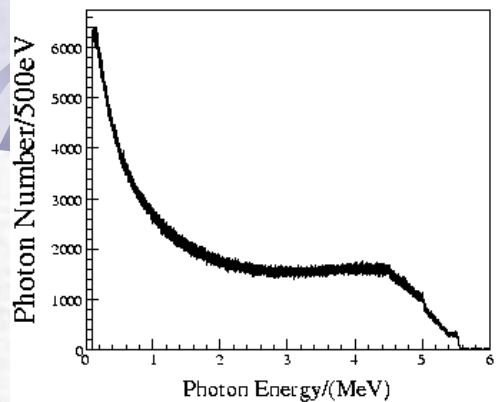
The commission of BEMS is fine. The systematical accuracy of the beam energy measurement is about 2×10^{-5} estimated by analysis of ψ' scan data

The BEMS plays an important role in the BES physics analysis and will play important role in the future

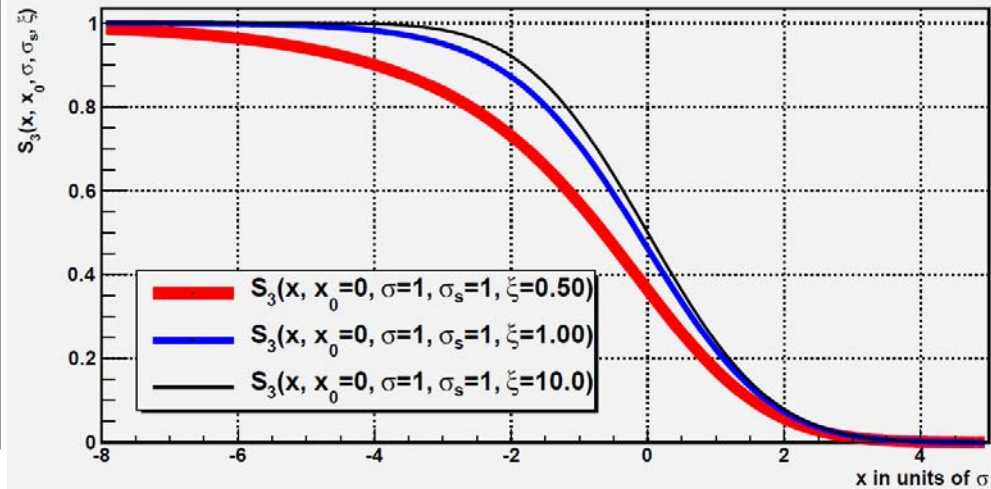
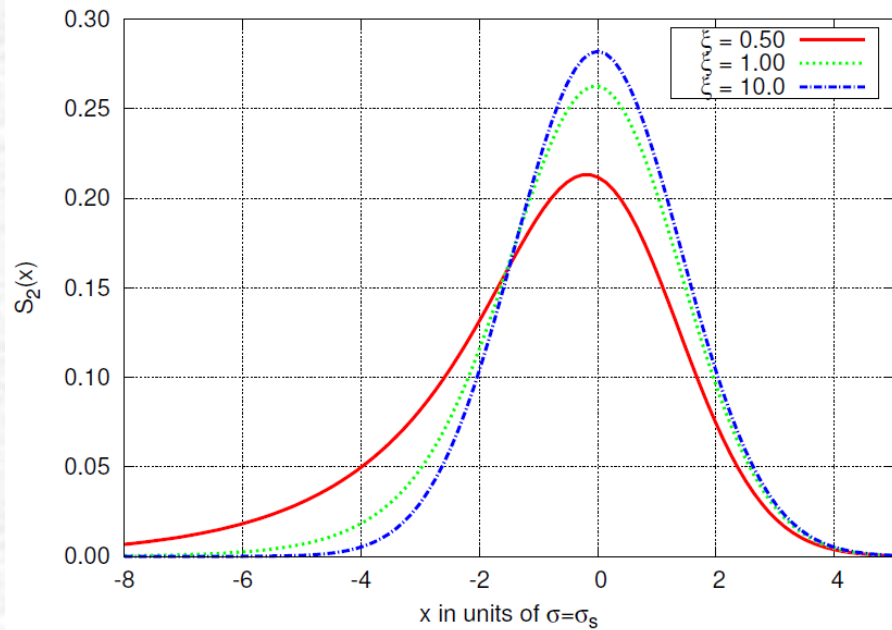
The BEMS also become a useful tool for the improvement of the running status of BEPCII

Thank you !

Backup



$$g(x, x_0) = \begin{cases} x < x_0 : & 1 \\ x > x_0 : & 0 \end{cases}$$



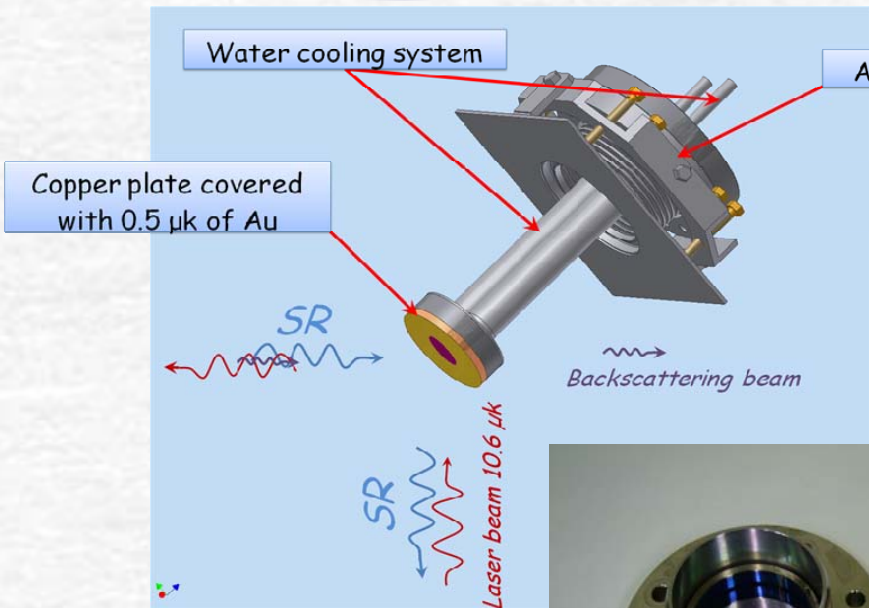
$$S_2(x, x_0, \sigma, \sigma_s, \xi) = \frac{N}{2\sqrt{2\pi}} \times$$

$$\times \left[\frac{1}{\sigma} \exp\left(\frac{\xi^2}{2} \left(1 + \frac{\sigma_s^2}{\sigma^2}\right) + \frac{\xi x}{\sigma}\right) \cdot \operatorname{erfc}\left(\frac{\xi(\sigma^2 + \sigma_s^2) + x\sigma}{\sqrt{2}\sigma\sigma_s}\right) + \right.$$

$$\left. + \frac{1}{\sqrt{\sigma^2 + \sigma_s^2}} \exp\left(-\frac{x^2}{2(\sigma^2 + \sigma_s^2)}\right) \cdot \operatorname{erfc}\left(-\frac{\xi(\sigma^2 + \sigma_s^2) + x\sigma}{\sqrt{2}(\sigma^2 + \sigma_s^2)\sigma_s}\right) \right]$$

$$S_3(x, \sigma, \sigma_s, \xi) = \int_x^{+\infty} S_2(y) dy$$

Copper mirror and High vacuum GaAs viewport

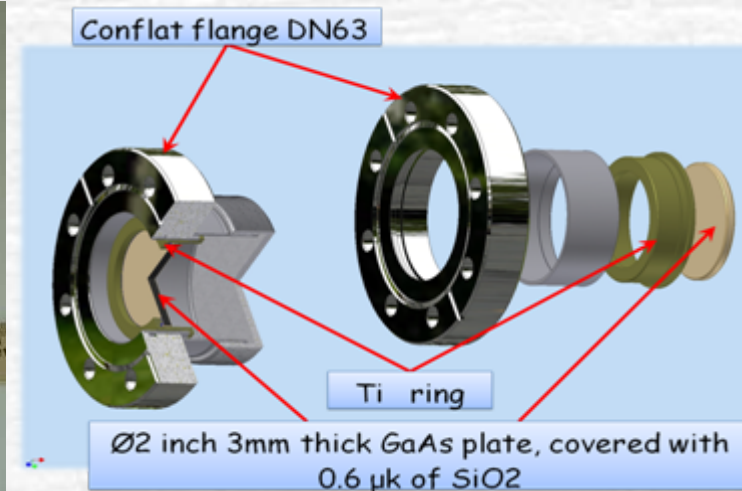


The mirror is mounted to the support.

Support can be turned by bending the vacuum flexible bellow, so the angle between the mirror and the laser can be adjusted as necessary.

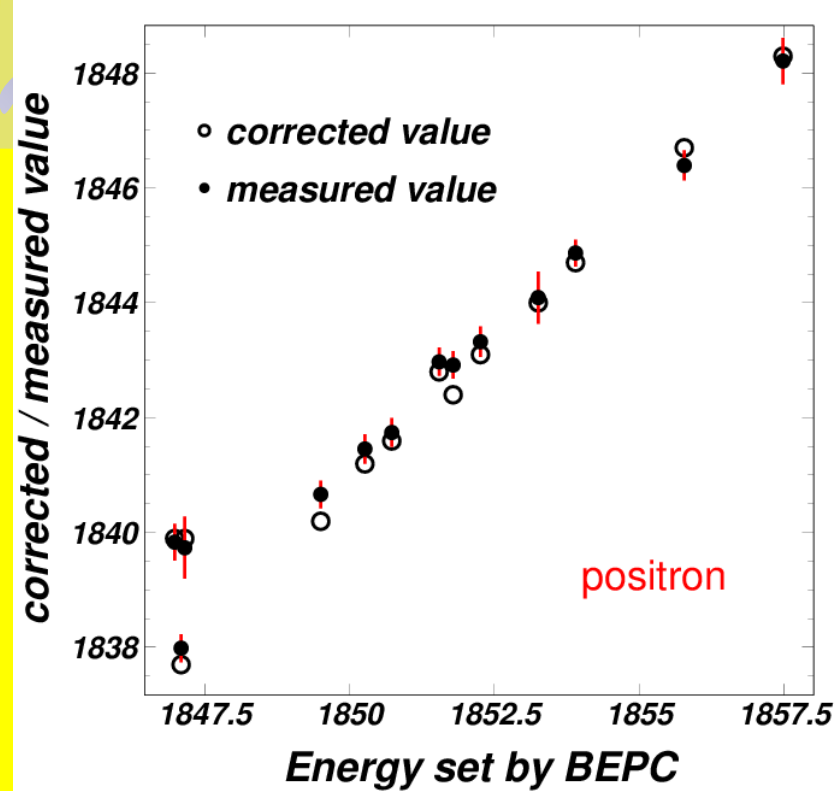
The SR is absorbed by the mirror. The extraction of heat is provided by the water cooling system.

The viewport is GaAs crystal plate with Ø2 inch and thickness of 3mm

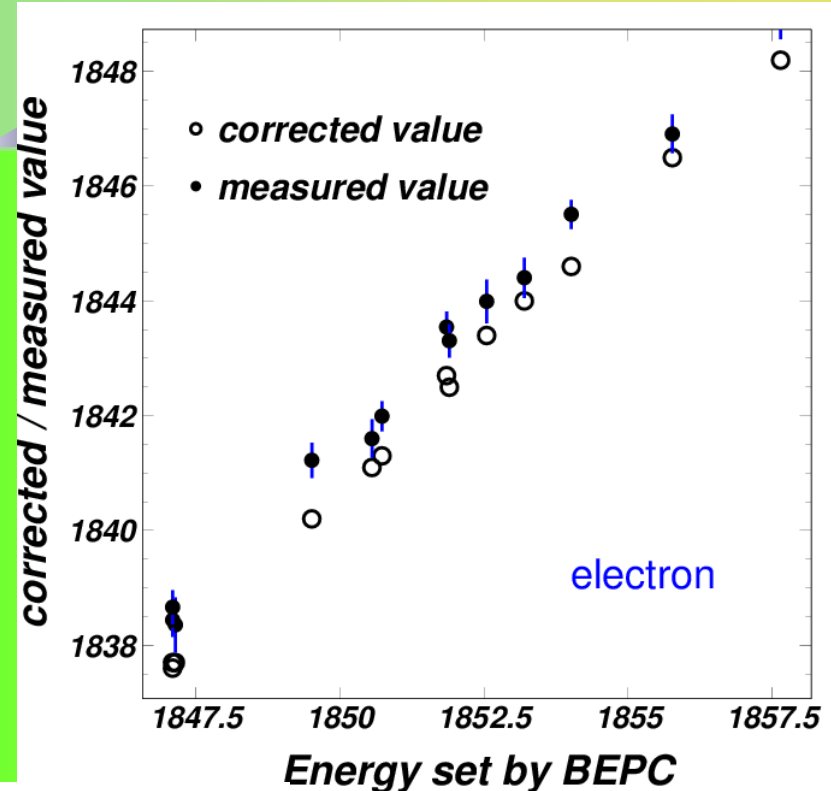


GaAs plate was covered with 0.6 μm of SiO_2 and brazed with lead alloy to titanium ring. The titanium ring was brazed with AgCu alloy to the stainless steel ring. The steel ring was welded to stainless steel DN40 flange.

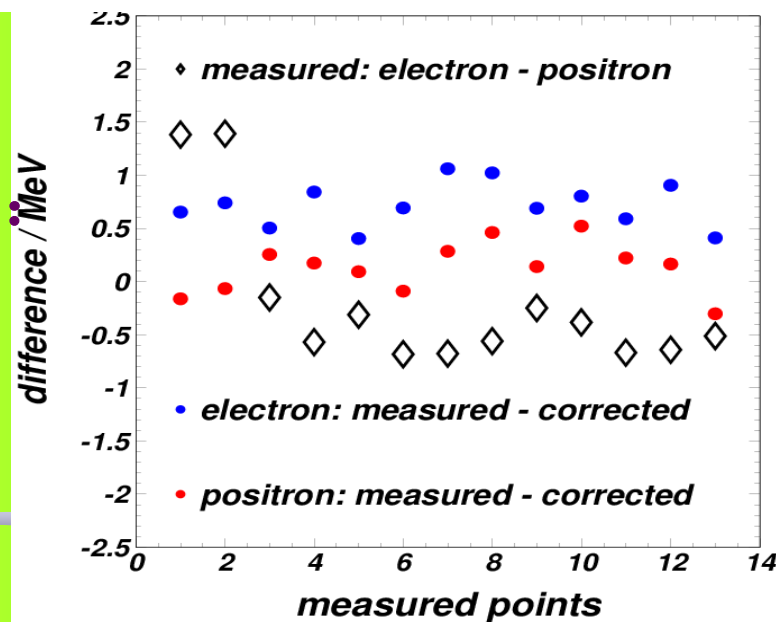
The viewport can be heated up to 250 $^{\circ}\text{C}$, has transparency $\sim 66\%$ at $\lambda = 10.6 \mu\text{m}$.



Energy diff.

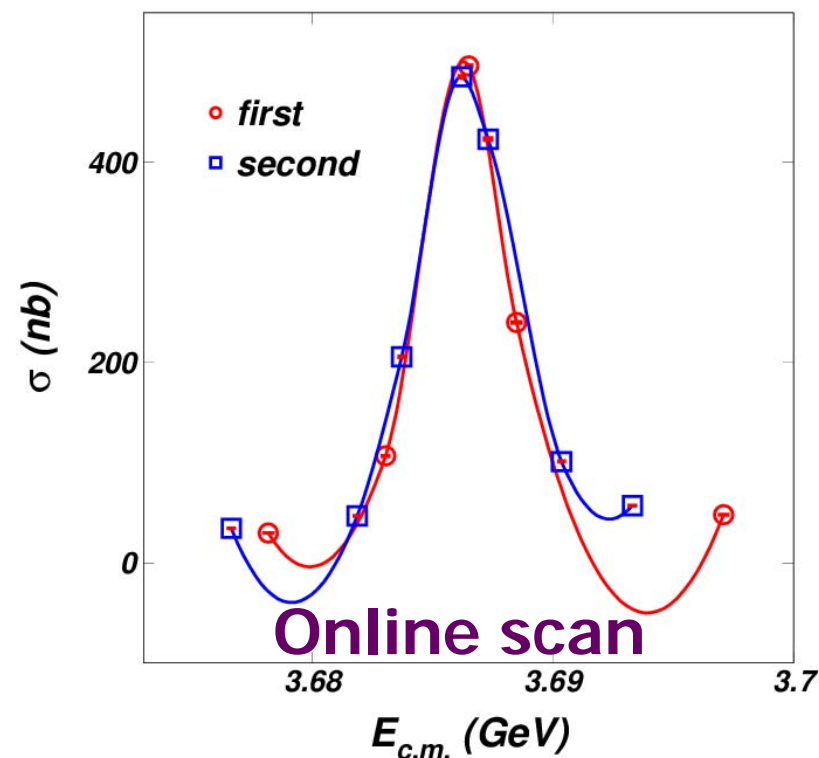


Corrected BEPCII
Measured BEMS:



Energy error
determined
by BEMS is
enlarged 3
times

Results of $\psi(3686)$ scan by

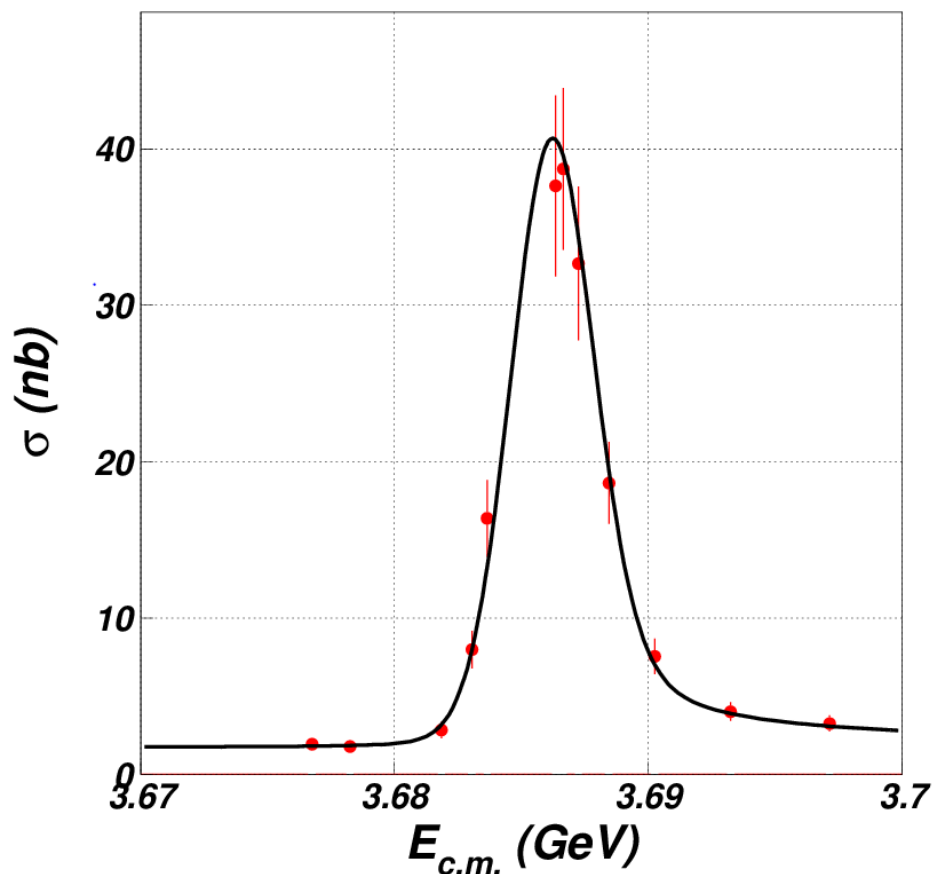


Offline fit:

$3686.08 \pm 0.02 \text{ MeV}$

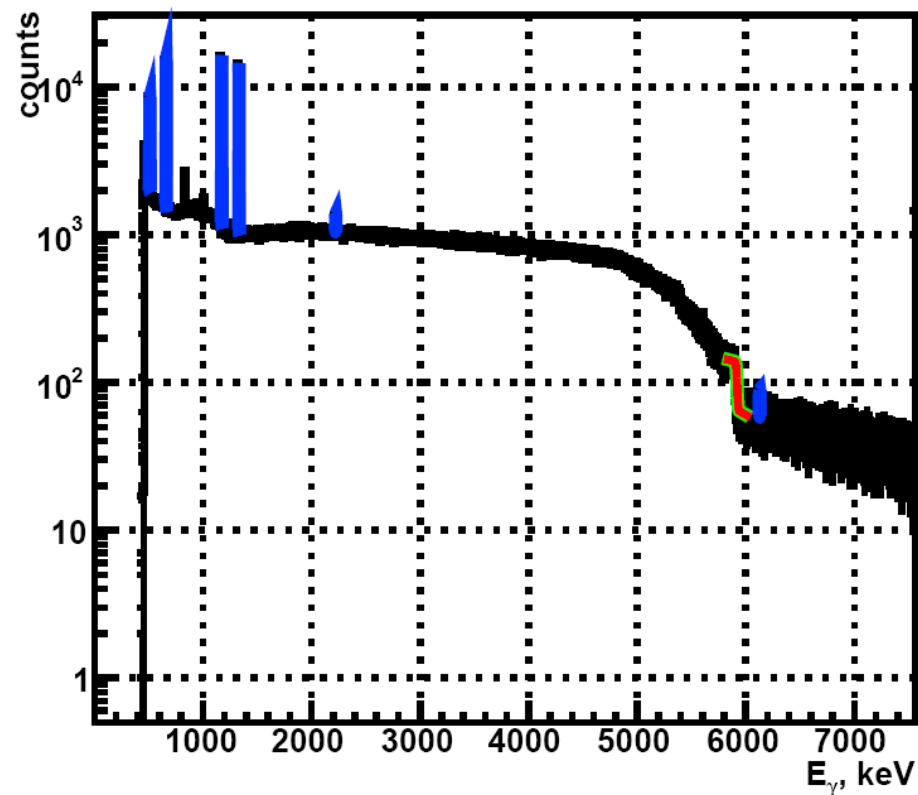
PDG2010:

$3686.09 \pm 0.04 \text{ MeV}$



- ❖ 无效率修正;
- ❖ 截面含任意倍数因子;
- ❖ 统计误差放大十倍.

| No. | Positron (MeV) | error (MeV) | relat. Err. (10 ⁻⁵) | Electron (MeV) | error (MeV) | relat. Err. (10 ⁻⁵) |
|-----|-------------------|----------------|------------------------------------|-------------------|----------------|------------------------------------|
| 1. | 1839.740 | 0.180 | 9.784 | 1838.355 | 0.160 | 8.703 |
| 2. | 1839.835 | 0.108 | 5.870 | 1838.443 | 0.098 | 5.331 |
| 3. | 1841.455 | 0.086 | 4.670 | 1841.604 | 0.112 | 6.082 |
| 4. | 1842.976 | 0.083 | 4.504 | 1843.545 | 0.092 | 4.990 |
| 5. | 1844.095 | 0.151 | 8.188 | 1844.405 | 0.118 | 6.398 |
| 6. | 1848.212 | 0.136 | 7.358 | 1848.895 | 0.112 | 6.058 |
| 7. | 1837.987 | 0.081 | 4.407 | 1838.663 | 0.099 | 5.384 |
| 8. | 1840.664 | 0.081 | 4.401 | 1841.224 | 0.103 | 5.594 |
| 9. | 1841.742 | 0.084 | 4.561 | 1841.990 | 0.088 | 4.777 |
| 10. | 1842.922 | 0.081 | 4.395 | 1843.305 | 0.096 | 5.208 |
| 11. | 1843.324 | 0.088 | 4.774 | 1843.992 | 0.127 | 6.887 |
| 12. | 1844.867 | 0.079 | 4.282 | 1845.508 | 0.086 | 4.660 |
| 13. | 1846.398 | 0.087 | 4.712 | 1846.911 | 0.113 | 6.118 |

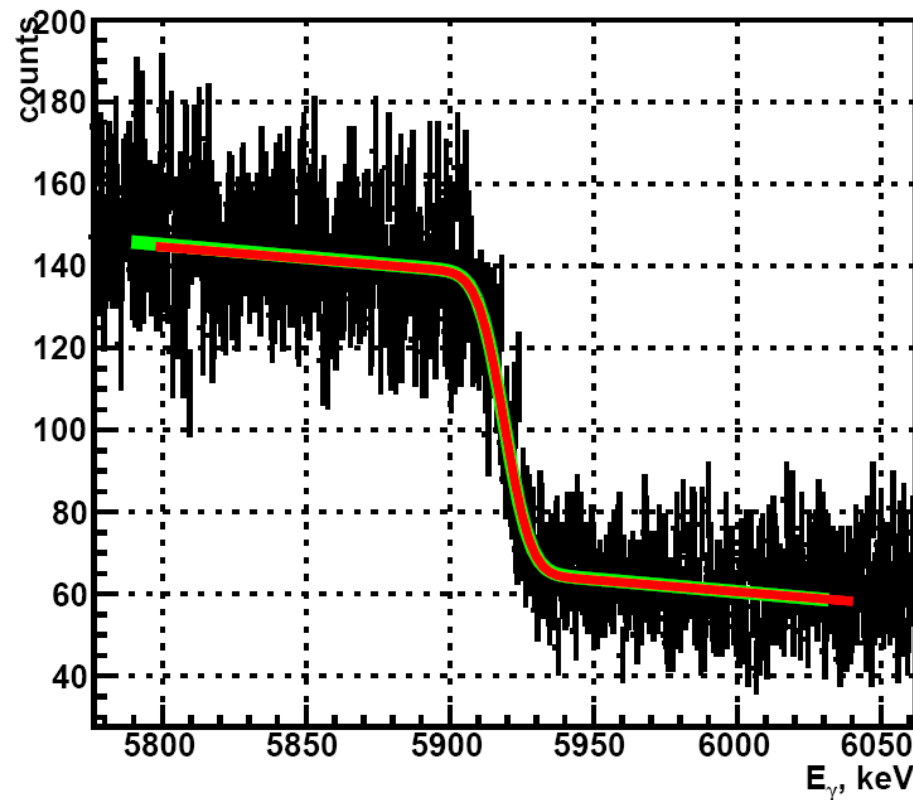


$$E_{\text{edge}} = 5919.332 \pm 0.519 \text{ keV}$$

$$\sigma_{E_{\text{edge}}} = 6.83 \pm 0.85 \text{ keV}$$

$$E_{\text{beam}} = 1840.664 \pm 0.081 \text{ MeV}$$

$$\sigma_{E_{\text{beam}}} = 1062.1 \pm 131.5 \text{ keV}$$



Uncertainty:
measured: 4.4×10^{-5}
designed: 5×10^{-5}

Important events

Optics system finished in 2008.8

Vacuum tube, connection part finished in 2009.9

Light monitor system finished in 2009.12

DAQ system finished in 2009.12

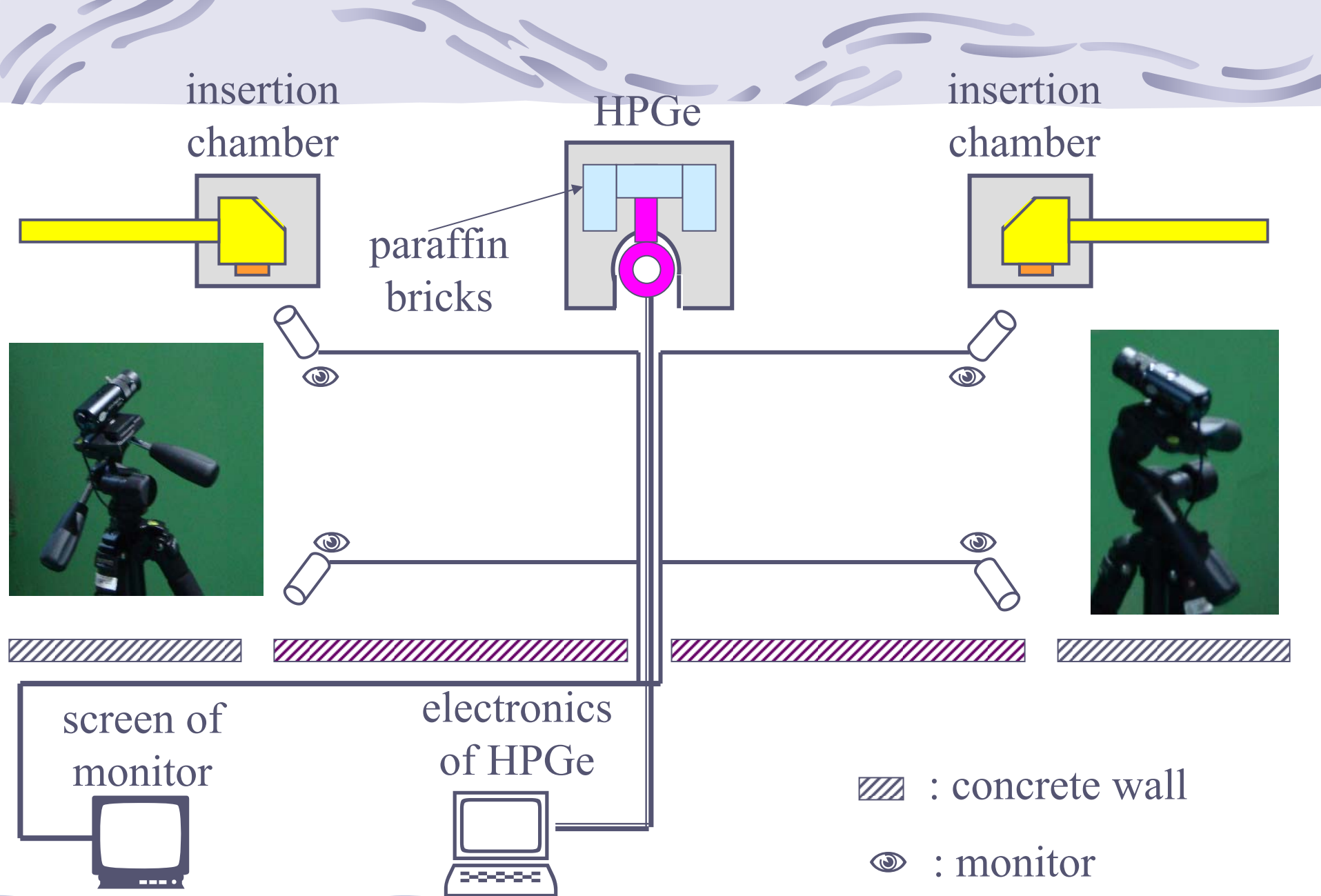
Laser system finished in 2010.1

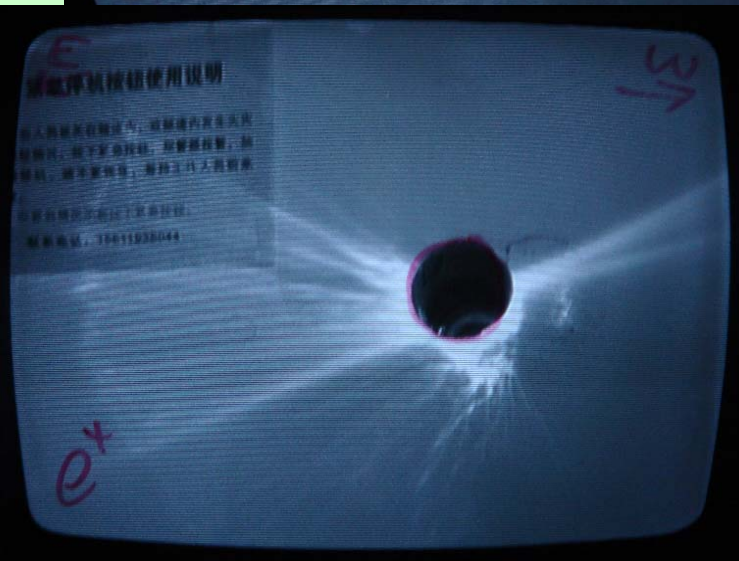
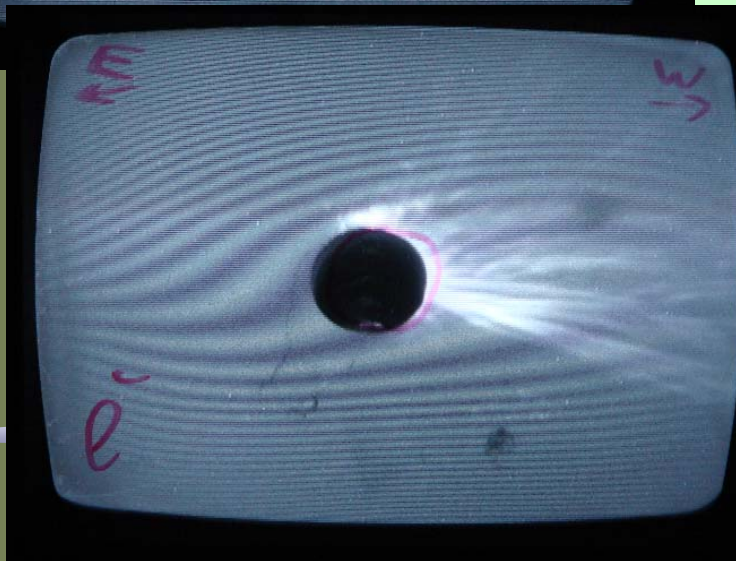
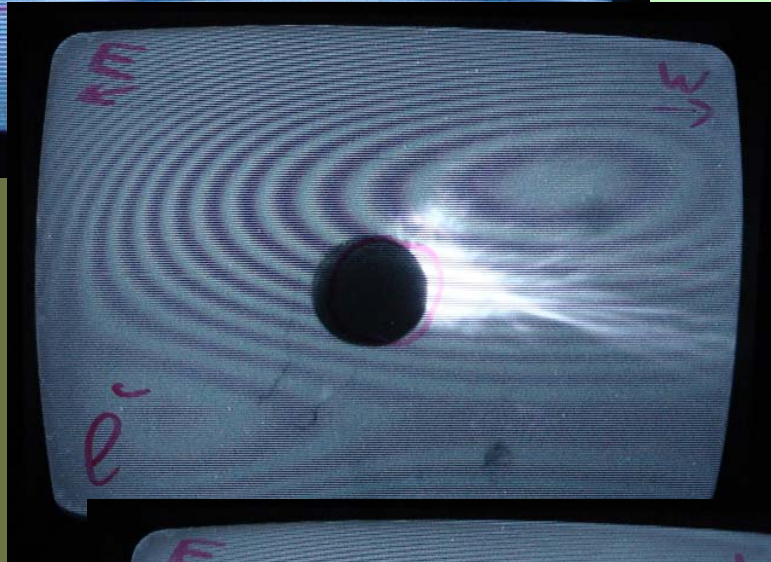
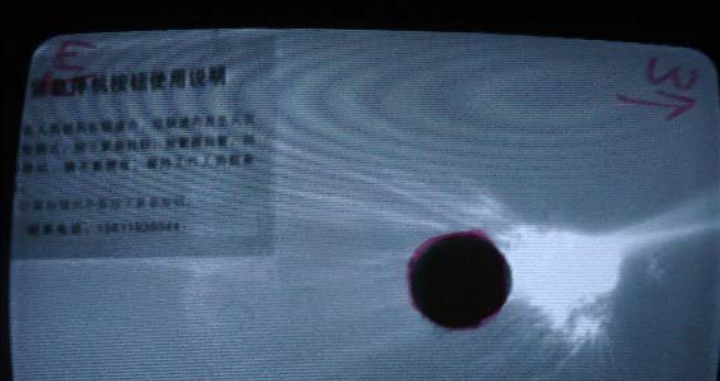
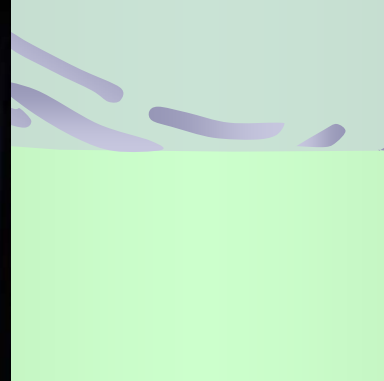
HPGe detector arrived in 2010.4

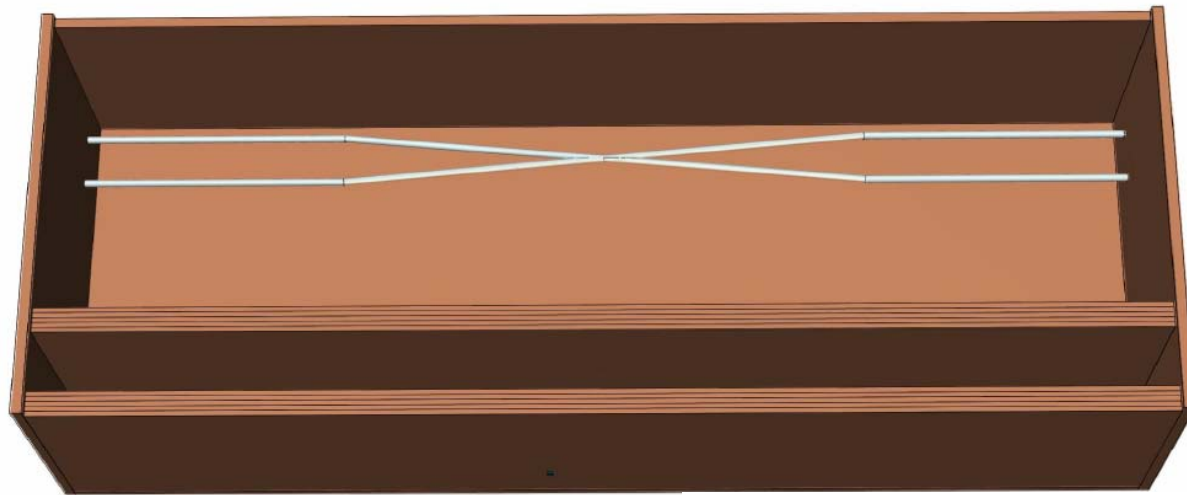
GaAs windows replacement finished in 2010.8

Laser alignment finished in 2010.9

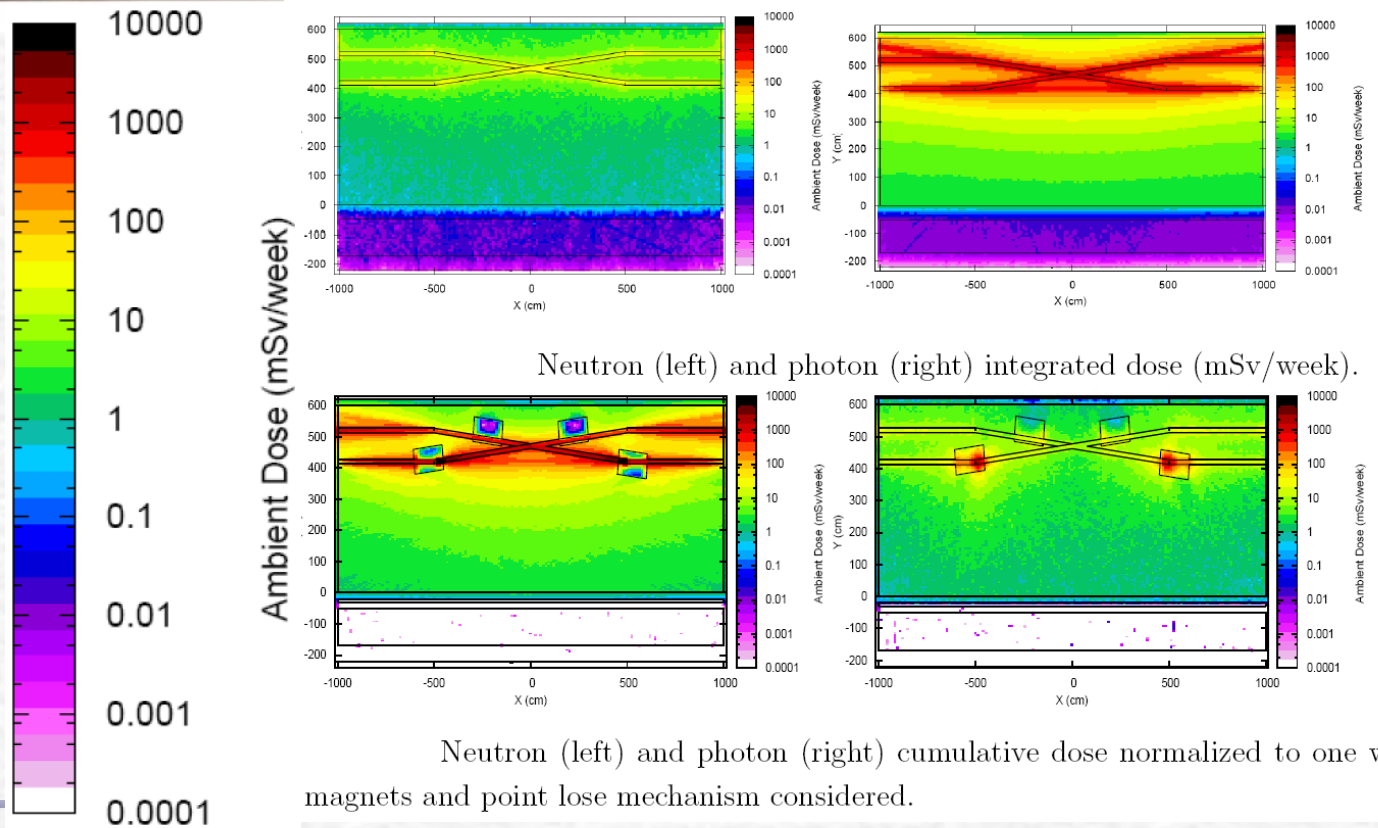
Total monitor system finished in 2010.9







FULKA: Construction geometry model of BEPCII north crossing point

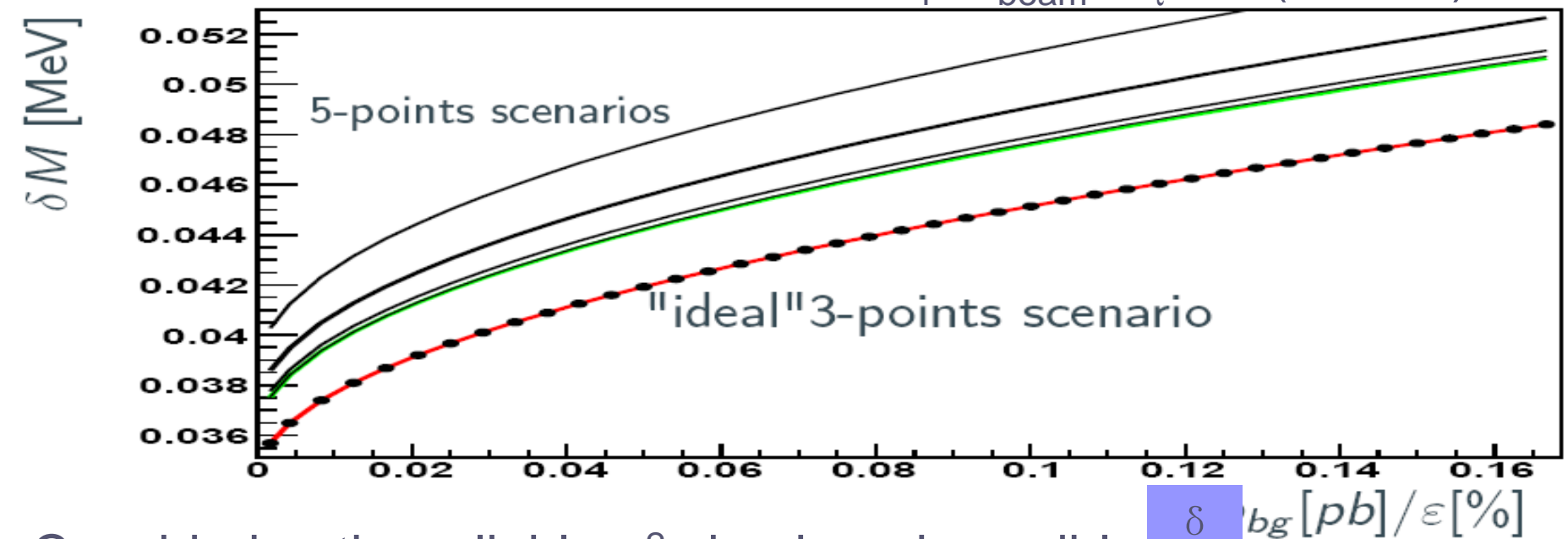


5-points scenario

K.Yu.Todyshev BINP

| Energy points | ΔE_1 | ΔE_2 | ΔE_3 | ΔE_4 | ΔE_5 |
|---------------------|--------------|--------------|--------------|--------------|--------------|
| Energy value (MeV) | -5. | -0.325 | -0.075 | +3.5 | +15 |
| Luminosity(percent) | 14 | 39 | 26 | 7 | 14 |

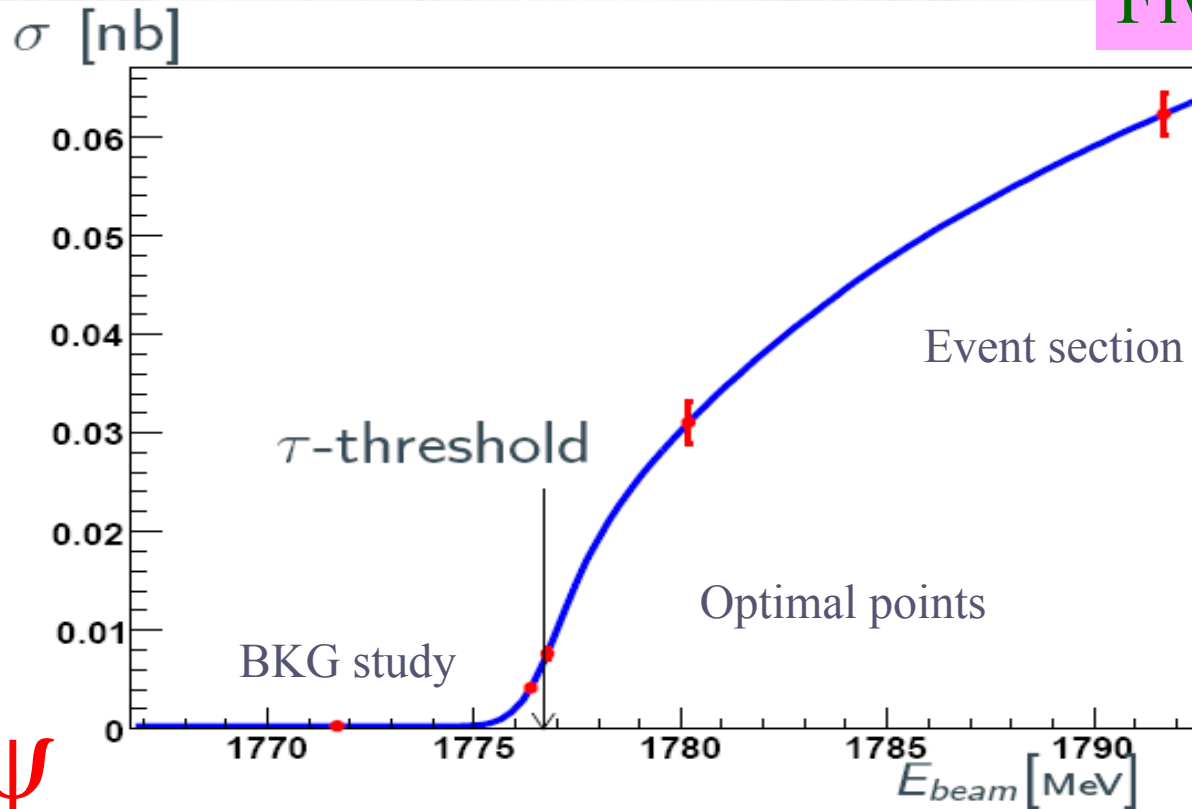
$$\Delta E_i = E_{\text{beam}} - m_{\tau}^{\text{PDG}} \quad (i = 1, 5)$$



Considering the reliable χ^2 check and possible efficiency and background variations

Data taking design

Five-points proposal



Min. Luminosity requirement

J/ψ : $1 \times 10^{31} \text{ cm}^{-1} \text{ s}^{-1}$

τ : $1 \times 10^{32} \text{ cm}^{-1} \text{ s}^{-1}$

ψ' : $3 \times 10^{32} \text{ cm}^{-1} \text{ s}^{-1}$

J/ψ

ψ'

①

②

③

④

⑤

⑥

⑦

⑧

⑨

⑩

Energy points for M_τ scan:

$M_\tau = 1776.82 \pm 0.16$ MeV (PDG2010)

**$E_{\text{cm}}(\text{MeV}) = [\text{J}/\psi \text{ scan}]; 3543.68, 3553.03,$
 **$[3553.3], 3553.53, 3560.68, 3583.68;$
 $[\psi' \text{ scan}].$****

**$E_{\text{beam}}(\text{MeV}) = [\text{J}/\psi \text{ scan}]; 1771.84, 1776.52,$
 **$[1776.65], 1776.77, 1780.34, 1791.84;$
 $[\psi' \text{ scan}].$****

Point order: $[1,8]; 2, 3, [9], 4, 5, 6; [7,10].$

12 days, for τ mass scan; 2 days for J/ψ & ψ' scan

Final uncertainty (sta. \oplus sys.) $< 100 \text{ keV}$